

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 236518US41YA		SERIAL NO. 10/673,138	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Eric J STRANG, et al.			
				FILING DATE September 30, 2003		GROUP 2128	
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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
/A.S./	AA	US 2002/0032495 A1	3/14/2002	Ozaki			
/A.S./	AB	US 5,719,796	2/17/1998	CHEN			
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		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
/A.S./	AI	CN 1335558A	2/13/2002	China (with Partial English Translation))	X		
/A.S./	AJ	JP 11-176906	7/2/1999	JAPAN (with English Abstract)			X
/A.S./	AK	KR 1999-071784	4/2/1999	Korea (with corresponding to US Patent Application No. 5,719,796 attached as a courtesy herewith)	X		
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	AT						<input type="checkbox"/> Additional References sheet(s) attached
Examiner /Akash Saxena/ (05/05/2011)					Date Considered 05/05/2011		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							